INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 26, 2025

IGI Report Number	LG759522587
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MODIFIED MARQUISE STEP CUT
Measurements	11.50 X 7.39 X 4.73 MM

GRADING RESULTS

Carat Weight	3.03 CARATS
Color Grade	F
Clarity Grade	VVS 2

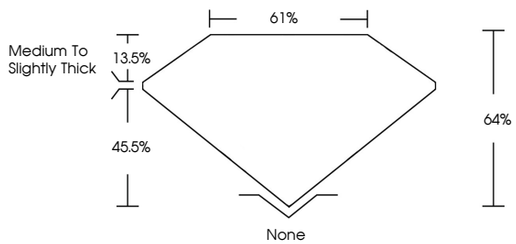
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	IGI LG759522587

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG759522587
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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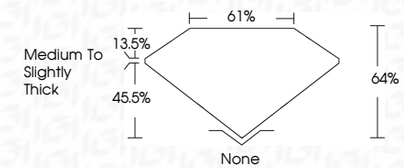

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IGI

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MODIFIED MARQUISE STEP CUT
11.50 X 7.39 X 4.73 MM

Carat Weight	3.03 CARATS
Color Grade	F
Clarity Grade	VVS 2
Depth	64%
Table	61%
Girdle	Medium To Slightly Thick
Culet	None
Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	IGI LG759522587

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